

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

DT05 Rec'd PCT/PTO 27 DEC 2004

In re patent application of

Masatomo SHIBATA, et al.

Serial No.: Not Yet Assigned

Group Art Unit: Not Yet Assigned

Filing Date: Concurrently Herewith

Examiner: Not Yet Assigned

For: POROUS SUBSTRATE AND FABRICATION METHOD THEREFOR, AND  
GaN SERIES SEMICONDUCTOR LAYERED SUBSTRATE AND  
FABRICATION METHOD THEREFOR

Honorable Commissioner of Patents  
Alexandria, Virginia 22313-1450

**PRELIMINARY AMENDMENT**

Sir:

Prior to examination on the merits and calculation of the filing fee, please amend the  
above-identified application as follows:

**INTRODUCTORY COMMENTS**

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2  
of this paper. Claims 5-11 and 13 have been amended to delete multiple dependency, and claims  
15-17 have been added accordingly. No new matter has been added.

**Remarks** begin on page 6 of this paper.